

Docket: 8021-160 (SS-18118-US)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Sun et al.

Examiner: Thanh V. Pham

Serial No.: 10/621,292

Group Art Unit: 2823

Filed: July 17, 2003

For: **METHOD OF FABRICATING SEMICONDUCTOR DEVICE USING A  
NICKEL SALICIDE PROCESS**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE**

Sir:

In response to the Office Action dated July 28, 2005, please reconsider the above-identified application in light of the following remarks/arguments.

**CERTIFICATE OF MAILING 37 C.F.R. §1.8(a)**

I hereby certify that this correspondence (and any document referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail, postage paid in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450, on September 27, 2005.

Dated: September 27, 2005

  
Scott L. Appelbaum



*Do not enter  
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10/11/2005  
(note: see item 7 of  
the attached)*